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Loss Analysis and Performance Optimization Pathways of 729-mV Voc Si Solar Cells with Poly-Si on **Locally-Etched Dielectric Passivating Contacts**

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INTRODUCTION

SiO

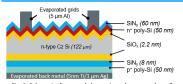
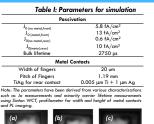
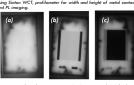


Fig. 1. Schematic diagram of the passivated contact solar cell with poly-Si on locally-etched dielectrics (pinholes omitted for clarity)

- Passivated contact solar cells fabricated with pinholes in ultrathin SiO2 and SiO2/SiN, layers using metal-assisted chemical etching (MACE) on planar or textured surfaces, at room temperature
- o Electron-selective n+ Poly-Si on Locally Etched Oxide (SiO_):(PLEO) Hole-selective p⁺ Poly-Si on Locally Etched Nitride Oxide
- (SiN,/SiO,): PLENO. Ref: C. L. Anderson et al., Adv. Energy Mater. 13 (11), 2203579.
- * C. L. Anderson fabricated and characterized the solar cells at NRE

DEVICE SIMULATION USING QUOKKA3





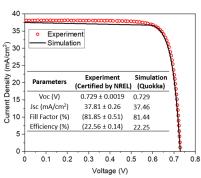


Fig. 3. Photoluminescence (PL) image of (a) before metallization (b) after metallization: front side (c) after metallization: rear side.

Experiment

Drawbacks

recombination

recombination

to parasitic

High rear contact

High current loss du

absorption in front

poly and rear Ti.

Hiah bulk

Fig. 4. Comparison of J-V for experin ental result (certified at NREL) with simulation results using Quokka3.

LOSS ANALYSIS

SiN_y/SiO_x (PLENO) passivating contacts.

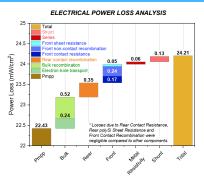


Fig. 5. Detailed electrical power loss analysis using Quokka3 of the assivated contact solar cell with poly-Si on locally-etched dielectrics

CURRENT LOSS ANALYSIS

Fig. 2. Idealized processing steps for the fabrication of electron-selective n⁺ poly-

Si on locally-etched SiO, (PLEO) and hole-selective p+ poly-Si on locally-etched

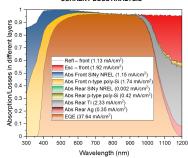
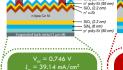


Fig. 6. Optical loss of current density using Sunsolve of the passivated contact solar cell with poly-Si on locally-etched dielectrics (Shading loss ~1.56% has not been shown here but included in electrical simulation by Quokka 3).

PATHWAY TO ACHIEVE HIGHER EFFICIENCY Current PLEO/PLENO structure



Step 2: Selective n-

polySi

- At front, n-Poly Si only below the metal contact.
- For detailed method please refer Better rear passivation K. Chen et al., IEEE J. Photovolt., 12 (3) pp. 678-689, 2022. Use of Al as rear metal contact instead of Ti/Ag.

42.43 mA/cm FF = 77.04 % n = 24.84 %

Bifacial PLEO/PLENO

Step 3: Bifacial Metal grids aligned at both sides

- Illuminated from both sides in simulation.
- Rear illumination: 10% of AM1.5.
- Rear SiNx ARC is non-absorbing (Simeon C et al., Prog. Photovolt. Res. Appl. 19(4), pp.406-416, (2011)).

EFFECT OF PARAMETER VARIATION IN DETAIL

Efficiency (%) PLEO/PLENO Cells 12 $J_{0(metal,rear)}$ (fA/cm 2) 23.32 ari~10 fA/cm 10 23.05 22.77 - 22 50 - 22.22 23.60 - 21 95 20 40 30 Bulk Lifetime (ms)

Fig. 6. Variation of efficiency with bulk lifetime and J PLEO/PLENO passivated contact solar cells.

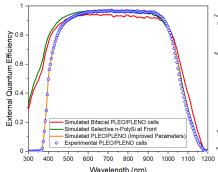


Fig. 7. Comparison of External Quantum Efficiency for different

Front Silv NRF Front Al metal -Rear p-type poly-Si 0.0 0 05 1 15 2 25 1.5 2 2.5 y NREL AR Rear Al met Rear p-type poly-Si Rear SiNy NREI Rear Silvy NRE 0 0.5 1 1.5 2 2.5 stical Loss in Current Density (mA/c

Step 1: Improving

narameters

Improve bulk lifetime

(5fA/cm²).

(~20 ms for practical

reasons like availability)

Fig. 8. Comparison of optical loss in current density for

- Experimentally 22.5% efficient passivated contact solar cells have been fabricated with deliberate introduction of pinholes using MACE
- o Increasing bulk lifetime to 20 ms and decreasing Joint J power loss
- Current loss analysis shows high absorption in rear Ti metal layer and front n-polyS
- Solutions have been proposed by improving the parameters, removing front n-polySi in noncontact regions and reducing rear metal contact in bifacial PLEO/PLENO structure to achieve n~25%
- In future, front SiN will also be changed as it is also absorbing in nature

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